



OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Supplemental Application Data Sheet**Application Information**

Application Type::	Divisional
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	METHOD FOR PRODUCING SOI WAFER AND SOI WAFER
Attorney Docket Number::	109725.01
Total Drawing Sheets::	4
Small Entity::	No

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Hiroji
Family Name::	AGA
City of Residence::	Gunma
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Naoto
Family Name::	TATE
City of Residence::	Gunma
Country of Residence::	Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Susumu
Family Name:: KUWABARA
City of Residence:: Gunma
Country of Residence:: Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Kiyoshi
Family Name:: MITANI
City of Residence:: Gunma
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	Division of	09/857,803	06/11/2001
Which is a	National Stage of	PCT/JP00/07111	10/13/2000
Assignee Information			
Assignee Name::		Shin-Etsu Handotai Co., Ltd.	
Street of mailing address::		4-2 Marunouchi 1-chome, Chiyoda-ku	
City of mailing address::		Tokyo	
Country of mailing address::		Japan	